



PATENT  
Attorney Docket No.: SAM-0465  
Customer No.: 29344

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyung-soo Kim, *et al.* Examiner: Chen, Kin Chan  
Serial No.: 10/685,738 Group Art Unit: 1765  
Filing Date: October 15, 2003  
Title: METHOD FOR MANUFACTURING MULTI-THICKNESS GATE  
DIELECTRIC LAYER OF SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

8/10/05

Date

A handwritten signature in black ink, appearing to read "Vanessa Marakas".

Vanessa Marakas

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

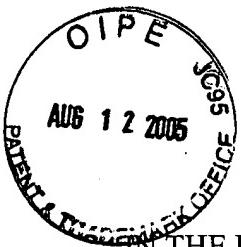
1. Amendment A in response to Office Action mailed on May 10, 2005; and
2. Return Postcard.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: August 10, 2005  
Mills & Onello LLP  
Eleven Beacon Street, Suite 605  
Boston, MA 02108  
Telephone: (617) 994-4900  
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J:\SAM\0465\amenda\transamendmenta.wpd

A handwritten signature in black ink, appearing to read "Anthony P. Onello".  
Anthony P. Onello, Jr.  
Registration Number 38,572  
Attorney for Applicant



Attorney Docket No.:SAM-465  
Application Serial No.: 10/685,738  
Reply to Office Action of: May 10, 2005

lfw

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Vanessa Marakas

Vanessa Marakas

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT A**

Sir:

The following is in response to the Office Action dated May 10, 2005, and is filed within the shortened statutory period of three months. Please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.